

<b>Notice of References Cited</b>	Application/Control No. 10/648,340	Applicant(s)/Patent Under Reexamination OGISHIMA ET AL.	
	Examiner W. Patty Chen	Art Unit 2871	Page 1 of 1

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*	B	US-2002/0063834	05-2002	Sawasaki et al.	349/130
*	C	US-2002/0075436	06-2002	Kubo et al.	349/129
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	K	US-			
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**NON-PATENT DOCUMENTS**

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